

CETR-UMT

- Comprehensive Materials Testing for Mechanical and Tribological Properties

Universal Nano, Micro, and Macro Materials Testers

One Precision Platform with Easily Interchangeable Modules

Applications

- Automotive, Aerospace
- Microelectronics
- Electric Contacts
- Metals, Ceramics
- Bio Materials, Medical
- MEMs, Optics
- Flexible & Hard Media
- Composite Materials
- Lubricants, Additives
- Thin Films, Coatings
- Polymers, Elastomers
- Paper, Fabric

Hardware			
Lower Specimen		Upper Specimen	Data Acquisition
X-Y Translation	Vacuum Chamber	XY Z Translation	16 Sensor Inputs
Horizontal & Vertical Rotation	Thermal Control	Rotation	16 Bit Resolution
Fast Oscillations	Humidity Control		200 kHz Data Rate

The Universal Nano+Micro+Macro Tester platform comes in three main configurations:

UNMT-1

For comprehensive nano- and micro-mechanical tests of thin films and nano-structured materials, with a load range of 1 μ m to 10 N.

UMT-2

For comprehensive **micro**-mechanical tests of coatings and materials, with a load range of 1 mN to 200 N.

UMT-3

For comprehensive **macro**-mechanical tests of lubricants, metal and ceramic materials, with a load range of 0.1 N to 1 kN.

Parameters Monitored

- X, Y, Z Forces
- X, Y, Z, Q Positions
- X, Y, Z Torques
- Wear Depth & Rate, N
- Acoustic Emission
- Temperature
- Humidity
- Electrical Capacitance
- Electrical Resistance
- Optical Images, Digital Video

Functional Testing

- Scratch
 - Adhesion
 - Delamination
 - Hardness
- Indentation
 - Young's Modulus
 - Storage Modulus
 - Hardness
- Fatigue
 - Multi-axis
 - Tension
 - Compression
 - Torsion
- Lubricity
 - Hydrodynamics
 - Mixed
 - Boundary
- Wear
 - Rotary
 - Linear
 - Reciprocating
 - Abrasive
 - Fretting
 - Galling
 - Seizure
- Adhesion
 - Pull-up
 - Striction
 - Scratch
- Environmental
 - Temperature
 - Humidity
 - Reciprocating
 - Abrasive
 - Fretting
- Strain
 - Elasticity
 - Plasticity
 - Creep
- Friction
 - Static
 - Dynamic
 - Stick-slip

Software		
Data Monitor Recording	Motion Control	Data Presentation
Real-Time Scope Mode Programmable Filtering	Programmable Velocities & Positions Forces & Torques Synchronized Motions	Data Analysis Data Statistics Charts Format Conversions

Technical Highlights

Multiple Tests on nano, micro and macro scales:

- Static and dynamic friction
- Ultra-low-speed (0.1 micro/s) stick-slip
- Adhesive, abrasive and scratching wear
- Pull-off adhesion/striction
- Scratch-adhesion and delamination
- Indentation, hardness and elastic modulus
- Multi-cycle, multi-axis fatigue
- Strain, elasticity, plasticity and creep
- Compression, tension and torsion
- Three-point bending

Multiple Sensors for in situ test monitoring:

- Ultra-precision force sensors of the proprietary technology and patented design (1 μ N to 1 kN)
- 6-D sensors for simultaneous measurements of 3 forces and 3 torques in all X, Y and Z axes
- High-frequency acoustic emission sensors of the proprietary design, ultra-sensitive to tiniest cracks and wear
- Wear and deformation sensors of micro (0.5 micron) and nano (20 nm) resolution
- Contact and surface electrical resistance (nOhms to MOhms) for detection of film failure or buildup
- Temperature and humidity sensors
- Integrated vision system for micro-positioning and digital video of the failure dynamics
- Integrated AFM for periodic nano-imaging of test surfaces, wear tracks, indents and scratches

Precision Servo-Control of loads, speeds, and positions for uniquely reproducible data and highly productive tests, e.g., repeatable different loads on different specimen areas for multi-test results from single tests

Multiple Synchronized linear and rotary motions of upper and lower specimens in all X, Y, and Z axes, including oscillations (up to 60 Hz), for sophisticated multi-axis tests, e.g., with spiral, zigzag or butterfly scratch/wear tracks

Multiple Chambers with computer-controlled temperature (-25 to 1000°C), humidity (10 to 95% RH), vacuum (up to 10^{-6} Torr), gases

Interchangeable motion and sensor modules are easily swapped within minutes



disc-on-disc module



pin-on-disk module with 1000°C chamber



block-on-ring module



reciprocation module with 300°C chamber



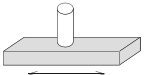
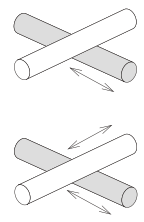
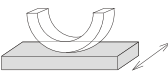
AFM module

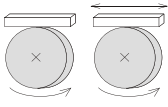

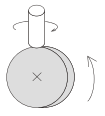



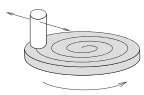
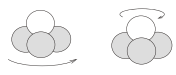
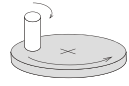

nano-indenter

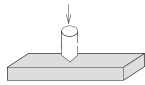
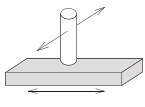
Test Schematics (Examples)		
Standard	Pin/Ball-on-Disk	Disc/Plate-on-Disc/Plate
	Block/Pin-on-Ring	Indenter-on-Plate
	Crossed-Cylinders	4-Balls
ISO/ASTM/DIN Standards		
Industrial	Bearings	Razor-on-Hair
	Valves	Brush-on-Teeth
	Connectors	Orthopedic Joints
	Commutators	Semicon Wafers
	Contact/Wires	Head-on-Disk
	Screw-in-Nut	Cutting Tools
	Pie-in-Chain	Contact Lenses
	Shaft-in-Seal	Optical Media/Lenses

UMT Drive Modules (Four Types)

Lower Linear Fast Reciprocation with Upper Linear Motion	
Lower Plate:	up to 150 mm
Lower Cylinder/Wire:	1 μ m to 25 mm
Reciprocation Frequency:	0.1 to 60 Hz
Reciprocation Stroke:	50 μ m to 25 μ m
Options:	fluid bath, environmental chamber
Wear & Fretting Tests	
Upper Pin/Ball/Block:	stationary
Multiple Wear Tracks:	auto-positioning, distance 0 to 75 mm, resolution 1 μ m
	
Cross-Cylinder Tests	
Upper Cylinder:	0.1 to 25 mm
Upper Tensioned Wire/Suture/Fiber:	1 μ m to 1 mm
Narrow Wear Track:	stationary upper sample
Wide Wear Track:	sliding upper sample, 0.001 to 10 mm/s
Multiple Wear Tracks:	auto-positioning 0 to 75 mm, resolution 1 μ m
	
Engine Tests	
Upper Piston Ring:	stationary
Lower Cylinder Liner:	reciprocating
	

Lower Rotation (horizontal axis) with Upper Linear or Rotary Motion	
Lower Ring/Bearing:	10 to 80 mm
Rotation:	cw/ccw, 0.1 to 5,000 rpm
Options:	fluid bath, environmental chamber
Block-on-Ring Tests	
Upper Block or Plate:	1 to 150 mm
Narrow Wear Track:	stationary block/plate, 0.001 to 10 mm/s
Wide Wear Track:	sliding block/plate, 0.001 to 10 mm/s
	
Ball/Pin-on-Ring Tests	
Upper Ball:	1.5 to 25 mm
Upper Pin:	1 to 25 mm, flat, spherical or conical end
	
Single/Multi-Crater Tests	
Upper Ball or Pin:	rotating cw/ccw, speeds 0.1 to 1,000 rpm
Positioning on new craters:	radial-range 360°, resolution 0.5 μ m, axial-range 75 mm, resolution 1 μ m
	

Lower Rotation (vertical axis) with Upper Linear or Rotary Motion	
Lower Disc:	up to 150 mm (optional 200 mm)
Rotation:	cw/ccw at two speed ranges: 0.1 to 5,000 rpm or 0.001 to 50 rpm
Upper Ball:	1.5 to 25 mm
Upper Pin:	cylinder 1 to 25 mm, flat, spherical or conical end
Options:	fluid bath, environmental chamber
Single-Radius Pin/Ball-on-Disc Tests	
Upper Pin or Ball:	stationary during test, automatic positioning on disc radii 0 to 75 mm, resolution 1 μ m
	
Spiral-Wear Pin/Ball-on-Disc Tests	
Upper Pin or Ball:	sliding radially on lower disc, speeds 0.001 to 10 mm/s, Lower disc angular speed auto-adjusted for constant linear speed
	
Four-Ball Tests	
Upper Ball:	stationary in the center
Three Lower Balls:	Immersed in fluid bath
	
Single/Multi-Crater Tests	
Upper Pin or Ball:	rotating cw/ccw, speeds 0.1 to 1,000 rpm
Positioning on new craters:	automatic radial positioning, range 75 mm, resolution 1 μ m, circumferential positioning, range 360°, resolution 0.5 μ m
	
Disc/Ring-on-Disc Tests	
Upper Pin or Ring:	up to 150 mm
Stationary or rotating:	cw/ccw, speeds 0.1 to 1,000 rpm
	

Lower High-Precision Linear with Upper Linear Motion	
Lower Plate:	up to 150 mm
Reciprocation Stroke:	75 mm
Positioning Resolution:	1 μ m
Linear Speed:	0.001 to 10 mm/s
Options:	fluid bath, environmental chamber
Single/Multiple Indentation Tests	
Upper Indenter:	Rockwell, Vickers, Berkovich
Positioning on new indents:	automatic, resolution 1 μ m
	
Butterfly Wear-Track Tests	
Upper Pin:	1 to 25 mm
Upper Ball:	1.5 to 25 mm
Upper Sliding:	synchronous with lower sliding
	

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